

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of

PAXTON et al.

Group Art Unit:

Application No.: TO BE ASSIGNED

Examiner:

Filed: February 23, 2004

Confirmation No.:

For: WAFER PROCESSING APPARATUS AND METHOD OF USE

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR 1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

The undersigned respectfully notes that copies of U.S. references are not required in applications filed after June 30, 2003

This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of the first Office Action on the merits in the present application. No certification or fee is required.

Respectfully Submitted,

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FORM PTO-1449 (modified)
 To: U.S. Department of Commerce
 (PW FORM PAT-1449)
 Patent and Trademark Office

Atty. Dkt. No.	M#	Client Ref.
	304351	P-1824.000-US

**INFORMATION DISCLOSURE STATEMENT
BY APPLICANT**

Applicant: PAXTON et al.

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Examiner: Group Art Unit:

U.S. PATENT DOCUMENTS

Examiner's Initials*	Document Number	Date MM/YYYY	Name (Family Name of First Inventor)	Class	Sub Class	Filing Date (if appropriate)
AR	5,431,700	07/1995	SLOAN			
BR	5,849,582	12/1998	CHEN et al.			
CR	6,137,088	10/2000	CHEN et al.			
DR	6,221,781	04/2001	SIEFERING et al.			
ER	6,307,184	10/2001	WOMACK et al.			
FR						
GR						
HR						
IR						
JR						
KR						
LR						
MR						
NR						
OR						

FOREIGN PATENT DOCUMENTS

	Document Number	Date MM/YYYY	Country	Inventor Name	English Abstract		Translation Readily Available	
					Enclosed	No	Enclose	No
PR								
QR								
RR								
SR								
TR								
UR								
VR								
WR								

OTHER (Including in this order Author, Title, Periodical Name, Date, Pertinent Pages, etc.)

XR				
YR				
ZR				
AAR				
BBR				
CCR				
DDR				

Examiner

Date Considered:

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.